

INFORMATION DISCLOSURE 1449

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Applicant: Cheng, et al.

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U.S. Patent Documents

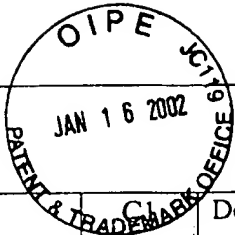
* Examiner's Initial	Ref	Document Number	Date	Name	Class	Subclass	File Date	Priority Date
km	A1	4,902,456	02/90	Yen, et al.				
	*A2	4,906,377	03/90	Yen, et al.				
	A3	4,990,294	02/91	Yen, et al.				
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	*A5	5,158,680	10/92	Kawai, et al.				
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Ref	Document Number	Date	Country	Class	Subclass	Translation
						Yes No
km	*B1	DE 34 44 387	07/85	Germany		
	*B2	EP 0 175 432	03/86	EPO		
	*B3	EP 0 217 482	04/87	EPO		
	B4	EP 0 299 459	01/89	EPO		
	B5	EP 0 340 732	11/89	EPO		
	B6	EP 0 343 247	11/89	EPO		
	B7	EP 0 559 149	09/93	EPO		
	B8	EP 0 803 281	10/97	EPO		
	B9	EP 0 855 212	07/98	EPO		
	B10	FR 2 566 003	12/85	France		
	B11	WO 00/44479	08/00	PCT		
	B12	WO 00/44480	08/00	PCT		
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Derwent Publication XP-002142276 Abstract of JP 04 354521

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*Indicates cited art that has been previously forwarded to the USPTO and is not enclosed.